



EV549568440

PTO/SB/21 (09-04)

Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

**TRANSMITTAL
FORM**

(to be used for all correspondence after initial filing)

Total Number of Pages in This Submission

10

Application Number

10/071,456

Filing Date

February 8, 2002

First Named Inventor

David L. Dickerson

Art Unit

2814

Examiner Name

A.D. Mai

Attorney Docket Number

MI22-1943

ENCLOSURES (Check all that apply)☐

Fee Transmittal Form

☐

Fee Attached

☒

Amendment/Reply

☐

After Final

☐

Affidavits/declaration(s)

☐

Extension of Time Request

☐

Express Abandonment Request

☐

Information Disclosure Statement

☐

Certified Copy of Priority Document(s)

☐Reply to Missing Parts/
Incomplete Application☐Reply to Missing Parts
under 37 CFR 1.52 or 1.53☐

Drawing(s)

☐

Licensing-related Papers

☐

Petition

☐Petition to Convert to a
Provisional Application☐

Power of Attorney, Revocation

☐

Change of Correspondence Address

☐

Terminal Disclaimer

☐

Request for Refund

☐

CD, Number of CD(s) _____

☐

Landscape Table on CD

☐

After Allowance Communication to TC

☐Appeal Communication to Board
of Appeals and Interferences☐Appeal Communication to TC
(Appeal Notice, Brief, Reply Brief)☐

Proprietary Information

☐

Status Letter

☒Other Enclosure(s) (please identify
below):

Postcard.

Remarks

Charge any additional fees required under 47 CFR 1.16 and 1.17 and credit overages to
Deposit Account No. 23-0925.**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm Name

Wells St. John P.S.

Signature

Printed name

D. Brent Kenady

Date

February 8, 2005

Reg. No.

40,045

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:

Signature

VIA EXPRESS MAIL EV 549568440

Typed or printed name

Date

February 8, 2005

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.



02-10-05
EV549568440

1Pw 2814

Application Serial No. 10/071,456
Response to November 10, 2004 OA

MI22-1943

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,456
Filing Date February 8, 2002
Inventor..... David L. Dickerson et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2814
Examiner A.D. Mai
Attorney's Docket No. MI22-1943
Customer No. 021567

Title: Semiconductor Constructions of Trenches with Insulative Material (As Amended)

RESPONSE TO NOVEMBER 10, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
Tel. 509-624-4276; Fax 509-838-3424
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Office Action dated November 10, 2004, Applicant amends and
remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

In the Title

On page 1, replace the Title with:

Semiconductor Constructions Having Polysilicon Layer Formed Against Trenches Filled
With Insulative Material (As amended)